



**ELECTRONIC COPY**

LG719534345  
Report verification at igi.org



June 25, 2025  
IGI Report Number **LG719534345**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **EMERALD CUT**  
Measurements **14.74 X 10.30 X 6.99 MM**  
**GRADING RESULTS**  
Carat Weight **10.28 CARATS**  
Color Grade **F**  
Clarity Grade **VVS 2**

**LABORATORY GROWN DIAMOND REPORT**

June 25, 2025  
IGI Report Number **LG719534345**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **EMERALD CUT**  
Measurements **14.74 X 10.30 X 6.99 MM**

**GRADING RESULTS**

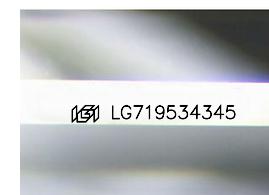
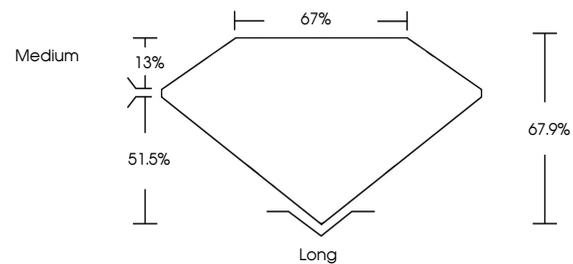
Carat Weight **10.28 CARATS**  
Color Grade **F**  
Clarity Grade **VVS 2**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG719534345**

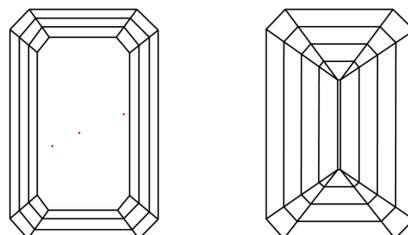
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

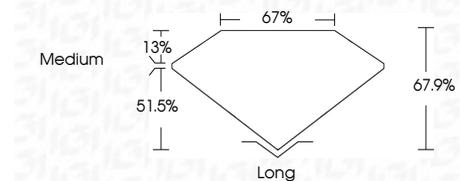
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG719534345**  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa



June 25, 2025  
IGI Report No LG719534345  
**EMERALD CUT**  
14.74 X 10.30 X 6.99 MM  
10.28 CARATS  
Color Grade **F**  
Clarity Grade **VVS 2**  
Depth **51.5%**  
Table **13%**  
Girdle **Medium**  
Culet **Long**  
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG719534345**  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa